

## Atmospheric trends of $CF_4$ and $C_2F_6$ inferred from air recovered from polar firn and ice.

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Tetrafluoromethane (CF<sub>4</sub>) and hexafluroethane (C<sub>2</sub>F<sub>6</sub>) are two potent greenhouse gases in the atmosphere which have very long lifetimes (>10000 years) and large global warming potentials. CF<sub>4</sub> and C<sub>2</sub>F<sub>6</sub> have known anthropogenic sources, mainly from the aluminium and semiconductor industries. CF<sub>4</sub> has previously [Harnisch et al. 1996] been shown to have a significant natural background of approximately 50% of contemporary concentrations. Through the analysis of polar firn air from 3 sites (North GRIP, Greenland; Berkner Island and Law Dome, Antarctica) and air recovered from ice at Law Dome, Antarctica our results confirm a natural background of 35 ± 1.5 pptv for CF<sub>4</sub> whilst showing that C<sub>2</sub>F<sub>6</sub> is entirely anthropogenic in origin with zero concentrations observed prior to ~1930. Both CF<sub>4</sub> and C<sub>2</sub>F<sub>6</sub> show rapid growth in the atmosphere post 1950 and the relationship between them is observed to change as a result of the different reductions in emissions from the aluminium industry coupled with growing emissions of C<sub>2</sub>F<sub>6</sub> resulting from its increased use in the semiconductor industry. These results have implications for both the 20<sup>th</sup> Century and pre-industrial radiative forcing calculations.

## Reference

Harnish, J., R. Borchers, P. Fabian, H. W. Gaggeler and U. Schotterer. Effect of natural tetrafluromethane, *Nature*, *384* (6604), 32-32, 1996.